

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Application of
HENNHÖFER ET AL.
Serial Number 09/032,305
Filed: Feb. 27, 1998

Group Art Unit: 1763

For: PROCESS FOR TREATING A
POLISHED SEMICONDUCTOR WAFER
IMMEDIATELY AFTER THE SEMI-
CONDUCTOR WAFER HAS BEEN
POLISHED

Information Disclosure Statement

Honorable Commissioner of Patents and Trademarks
Washington, D.C. 20231

Sir or Madam:

I, Wolfgang Staudacher, associated with the preparation and prosecution of the above-identified application, residing at Seebauerstraße 4, 81735 München, Germany, wish to call the attention of the Patent Examiner to the references enumerated on the enclosed PTO Form-1449.

I believe the documents enumerated on the enclosed Form PTO-1449 and attached thereto, are cited in the enclosed European Search Report and may be material to the examination of the application.

Therefore, it is respectfully requested that the foregoing Information Disclosure Statement be considered by the Examiner and incorporated into the file of this application.

I wish to comment as follows concerning the prior art references enumerated on PTO Form-1449:

Patent Abstracts of Japan, JP 02 275629 (Osaka Titanium Co. Ltd.) is already in English language.

EP 0 805 000 A1 is already in English language.

US 4,050,954 is already in English language.

EP 0 718 873 A2 is already in English language.

Patent Abstracts of Japan, JP 04 129668 (Asahi Glass Co. Ltd.) is already in English language.

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C. G. Guev
11/25/98

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GAM 1763



PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

APPLICANTS: HEINRICH HENNHOFFER ET AL
SERIAL NO.: 09/032,305 GROUP: 1763
FILED: FEBRUARY 27, 1998
TITLE: PROCESS FOR TREATING A POLISHED SEMICONDUCTOR ...

SUBMISSION OF INFORMATION DISCLOSURE STATEMENT
OF WOLFGANG STAUDACHER

ATTN: BOX NON-FEE AMENDMENT
Ass't. Commissioner for Patents
Washington, D.C. 20231

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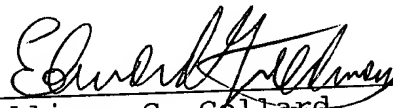
Dear Sir:

Applicants wish to bring to the attention of the Patent Examiner the references listed on the enclosed Form PTO-1449 and the attached Information Disclosure of Wolfgang Staudacher. These references were cited in the European Search Report, a copy of which is attached, along with copies of the references.

It is respectfully requested that the foregoing Information Disclosure Statement (IDS) be incorporated into the official file of the present patent application.

Respectfully submitted,

HEINRICH HENNHÖFER ET AL.

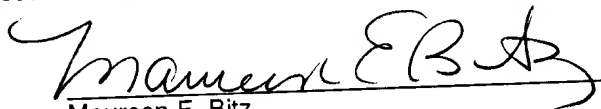
By: 
Allison C. Collard
Edward R. Freedman
COLLARD & ROE, P.C.
Attorneys for Applicants

1077 Northern Boulevard
Roslyn, New York 11576
(516) 365-9802

Encs: Information Disclosure Statement of Wolfgang Staudacher
Form PTO-1449 w/copies of five (5) references
Copy of European Search Report

I hereby certify that this correspondence is being deposited with the U.S. Postal Service as first class mail in an envelope addressed to: Assistant Commissioner of Patents, Washington, D.C. 20231, on June 15, 1998

Date: June 15, 1998


Maureen E. Bitz